

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Akihoki ISHIBASHI et al.

Serial No. 09/692,211

Filed: October 20, 2000

For: METHOD OF FABRICATING

NITRIDE SEMICONDUCTOR

DEVICE

Attention: Applications Branch  
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## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20131, on 3/6/01

CORRECTION TO TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

On February 14, 2001, Applicants respectfully submitted a certified copy of the priority document to perfect the claim for priority. However, Applicants have identified a typographical error. In particular, Japanese Patent Application No. 11-299640 was incorrectly listed as being filed on October 10, 1999. The correct filing date should be listed as October 21, 1999.

A certified copy of the priority document was previously submitted, and therefore, Applicants have not attached an additional copy of priority document.

Respectfully submitted,

  
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